

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerome M. Eldridge et al.

Title: ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW ASYMMETRICAL TUNNEL
BARRIER INTERPLAY INSULATORS

Docket No.: 1303.045US1
Filed: February 20, 2002
Examiner: Tu-Tu Ho

Serial No.: 10/081,818
Due Date: June 14, 2008 (Saturday)
Group Art Unit: 2818
Confirmation No.: 3148

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ Amendment and Response under 1.111 (13 pg.)
- ☒ Supplemental Information Disclosure Statement (4 pgs.), Form 1449 (8 pgs.) Copies of Cited References (17).

If not provided for in a separate paper filed herewith, please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

By: Robert B. Madden
Robert B. Madden
Reg. No. 57,521

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 16 day of June, 2008.

Leshere Wolfe
Name

Leshere Wolfe
Signature